

INFORMATION DISCLOSURE CITATION

IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)

AKM-00601

Application No.

10/074,756

Applicant

Fumihiko FUJISHIRO, et al.

Filing Date

February 12, 2002

Group Art Unit

2875-2673

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA						
AB						
AC						
AD						
AE						

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
AF	2000-90884	3-31-00	JP			
AG	10-222083	8-21-98	JP			
AH	2002-93379	3-29-02	JP			
AI	2000-500277	1-11-00	JP			
AJ						
AK						

OTHER DOCUMENTS (Including author, Title, Date, Pertinent Pages, Etc.)

AK	
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EXAMINER

PRABODH M. DHARIA

DATE CONSIDERED

02/23/04.

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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To be determined

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	AA					
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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
	AF 2000-500277	1/11/2000	JP			
	AG 2000-500916	1/25/2000	JP			
	AH 2000-503801	3/28/2000	JP			
	AI 2000-500917	1/25/2000	JP			
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OTHER DOCUMENTS (Including author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	6,060,828	05/09/2000	Frank Vollkommer, et al.			
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RECEIVED**FEB 13 2004****Technology Center 2600****FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
AL	2000-90884	03/31/2000	JP				X
AM							
AN							
AO							
AP							
AQ							

OTHER DOCUMENTS

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